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SERIAL NUMBER 10/642,657	FILING DATE 08/19/2003 RULE	CLASS 430	GROUP ART UNIT 1756	ATTORNEY DOCKET NO. Q77049
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APPLICANTS

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** CONTINUING DATA *****

None, JSR

** FOREIGN APPLICATIONS *****

JAPAN 238576/2002 08/19/2002 - JSR

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 11/13/2003

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	Examiner's Signature <i>JSR</i> Initials		1	14	5

ADDRESS

23373
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TITLE

Method of producing a glass substrate for a mask blank, method of producing a mask blank, method of producing a transfer mask, method of producing a semiconductor device, glass substrate for a mask blank, mask blank, and transfer mask

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees
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